

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q87956

Fumio ODAKA

Appln. No.: 10/534,531

Group Art Unit: 1755

Confirmation No.: 7017

Examiner: Karl E. GROUP

Filed: May 12, 2005

For: SILICON CARBIDE SINTERED BODY AND MANUFACTURING METHOD  
THEREOF

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of three months, extending the time for responding to the Office Action of July 24, 2007 to January 24, 2008.

The statutory fee of \$1050.00 is being charged to Deposit Account No. 19-4880 via EFS payment screen. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,



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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: January 23, 2008